

IPR

Docket No.: 050432-0601

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of

Minh Van NGO, et al.

Application No.: 10/617,451

Filed: July 11, 2003

: Customer Number: 20277

: Confirmation Number: 3500

: Group Art Unit: 2812

: Examiner: LINDSAY, Walter Lee Jr.

For: PECVD SILICON-RICH OXIDE LAYER FOR REDUCED UV CHARGING

INFORMATION DISCLOSURE STATEMENT

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action is attached for the Examiner's information. Please note that copies of U.S. Patent

10/617,451

Nos. 5,290,727 and 5,602,056, which were cited in January 11, 2005 International Search Report, are not enclosed as they were submitted with the Information Disclosure Statement filed April 15, 2005.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

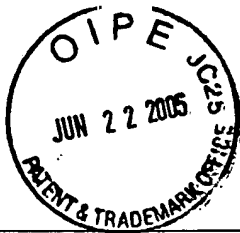
A handwritten signature in black ink, appearing to read 'M. Steiner'.

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**Please recognize our Customer No. 20277
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SHEET 1 OF 1

INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

(PTO-1449)

ATTY. DOCKET NO.
050432-0601SERIAL NO.
10/617,451APPLICANT
Minh Van NGO, et al.FILING DATE
July 11, 2003GROUP
2812

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US 5,290,727	03/01/94	Jain et al.	
		US 5,602,056	02/11/97	Jain et al.	
		US 2003/096476 A1	05/22/03	Bloom et al.	
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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number 4-Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.